



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re application of

Kazuhiro IKURUMI et al.

Serial No. 09/826,827

Filed April 6, 2001

: Confirmation No. 5095

: Docket No. 2001\_0409A

: Group Art Unit 2817

: Examiner Justin P. Bettendorf

TECHNOLOGY CENTER 2800

8/ Elect  
G. Stanley  
11-12-02

METHOD AND APPARATUS FOR  
ADJUSTING IMPEDANCE OF  
MATCHING CIRCUIT

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

ELECTION

Assistant Commissioner for Patents,  
Washington, D.C.

Sir:

Pursuant to the requirement contained in the Office Action mailed October 8, 2002,  
Applicants hereby elect Group I, claims 1-13, drawn to a method of impedance matching.

In view of this election, a full examination on the merits of the present application is  
respectfully requested.

Respectfully submitted,

Kazuhiro IKURUMI et al.

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November 1, 2002